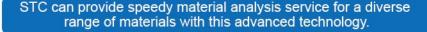


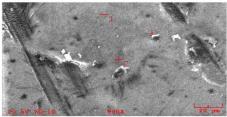


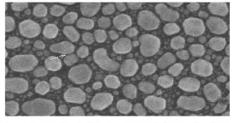
Scanning Electron Microscope (SEM) is a type of electron microscope that produces images of a sample by scanning the surface with a focused beam of electrons. The electrons interact with atoms in the sample, producing various signals that contain information about the sample's surface topography, construction and composition.

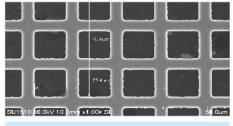
STC has introduced the latest advanced Scanning Electron Microscope (SEM), the highest resolution can reach 3nm, equipped with secondary electron probe, 4-axis backscattered electron probe and Energy Dispersive-Spectrometry (EDS). This equipment is widely used in metal, semi-conductor, ceramic, textiles, etc., it can be used for morphology analysis in material surface and chemical elements in the micro analysis.



Test Item	Test Standard / Requirement
Microstructure Analysis	SE, BSE
EDS Analysis (Chemical Composition)	ASTM E1508, GB/T 17359
Coating Thickness Test	ASTM B748
Fracture Analysis	Fracture keep clean
Particle Dimension Analysis	Grain diameter greater than 1 microns
Inclusion Analysis	Inclusion greater than 1 microns
Element Segregation Analysis	1







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